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P (E)08/62.022494

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

· Exar

Examiner: A. A. Mathews

Hiroshi KUROSAWA

: Group Art Unit: 2851

Application No.: 10/050,581

: Confirmation No.: 7091

Filed: Jaunary 18, 2002

)

For: EXPOSURE METHOD AND APPARATUS, AND

DEVICE MANUFACTURING METHOD

) December 10, 2003

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

X

No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED							
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	17	MINUS	32	= 0	x \$9 \$18	\$0.00	
INDEP. CLAIMS	4	MINUS	7	= 0	x \$43 \$86	\$0.00	
Fee for Mu	\$0.00						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00	

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
	Respectfully submitted,

Attorney for Applicants

Jack S. Cubert

Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200 SEW/JSC/dc

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:)	
	:	Examiner: A. A. Mathews
Hiroshi KUROSAWA)	
	:	Group Art Unit: 2851
Application No.: 10/050,581)	
	:	Confirmation No.: 7091
Filed: January 18, 2002)	
	:	
For: EXPOSURE METHOD AND APPARATUS,)	
AND DEVICE MANUFACTURING METHOD	:	December 10, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated September 11, 2003, please amend the aboveidentified application as follows:

TECHNOLOGY CENTER 2800

DEC 15 2003